IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 09/910,110)	
Inventors: Peter V. Loeppert et al.)	
Title: Raised Microstructure of Silicon)	
Based Device)	

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Technology Center 2000

Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Enclosed herewith is the original Power of Attorney and Revocation of Prior Powers for filing in the above-identified application. All future correspondence concerning this matter should be directed to the undersigned.

Respectfully submitted,

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Date: August 18, 2003

I hereby certify that this paper is being deposited with the United States Postal Service, first class postage prepaid, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria,

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Anthony G. Sitko

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